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Bib Data Sheet

CONFIRMATION NO. 6589

SERIAL NUMBER 10/600,332	FILING DATE 06/23/2003 RULE	CLASS 438	GROUP ART UNIT 2812	ATTORNEY DOCKET NO. P68917US0
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~~**~~ CONTINUING DATA ***** *none*** FOREIGN APPLICATIONS ***** *SKC*
REPUBLIC OF KOREA 2002-42462 07/19/2002

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 08/26/2003

Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance		DRAWING 7	CLAIMS 12	CLAIMS 1
Verified and Acknowledged	<i>Hanesteben SKC</i> Examiner's Signature Initials				

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TITLE

Method for forming device isolation film of semiconductor device

 All Fees